

Notice of References Cited

	•		
Application/Control No. 09/871,561	Applicant(s)/Patent Under Reexamination CHO ET AL.		
Examiner	Art Unit		
Daniel A. Nolan	2654	Page 1 of 1	

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,134,242 A	10-2000	Aftelak, Steven Basil	704/212
	В	US-6,070,089 A	05-2000	Brophy et al.	704/221
	С	US-6,622,017 B1	09-2003	Hoffman, Ted L.	455/419
	D	US-5,790,957	08-1998	Heidari, Alireza Ryan	455/553.1
	E	US-6,421,353 B1	07-2002	Kim, Yun-Hyang	370/465
	F	US-5,729,536	03-1998	Doshi et al.	370/398
	G	US-5,550,893 A	08-1996	Heidari, Alireza R.	455/553.1
	н	US-			
	1	US-			
	J	US-			
	к	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 11-178065	07-1999	Japan	Katayanagi et al	H04Q 7/38
	0	JP 10-243453	09-1998	Japan	Kiuchi et al	H04Q 7/38
	Р					
	Q					
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)		
	U			
	V			
	w			
	х			

^{*}A copy of this reference is not being furnished with this Office action. (See MPEP § 707 05(a)) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.